

SEP 13 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 100191)

Applicant: Schroeder et al.

Application No. 10/660,379

Filed: September 11, 2003

For: CHEMICAL-MECHANICAL
POLISHING COMPOSITION
AND METHOD FOR USING
THE SAMEExaminer: George A. Goudreau
Art Unit: 1763Certificate of Facsimile Transmission

I, Mariejose Monsalve, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted to the Mail Stop indicated below by facsimile being sent to the USPTO's central facsimile number (703) 872-9306 on

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RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Office Action dated July 14, 2006, please enter the following amendments and consider the following remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.

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